IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States	s Patent Application of:) Docket No.:	020732-97.668
Applicant:	Rath, Melissa K., et al.	Examiner:	Hoa Van Le
Application No.:	10/792,038	Art Unit:	1752
Date Filed:	March 3, 2004	Conf. No.:	4823
Title:	COMPOSITION AND PROCESS FOR POST-ETCH REMOVAL OF PHOTORESIST AND/OR SACRIFICIAL ANTI- REFLECTIVE MATERIAL DEPOSITED ON A SUBSTRATE	Customer No.:	
		24239	

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Sir:

referen respect applica	ce(s) lis fully re tion, and	C.F.R. §1.56, the attention of the Patent and Trademark Office is hereby directed to the sted on the attached PTO/SB/08A. One copy of each reference is attached. It is quested that the information be expressly considered during the prosecution of this it that the reference(s) be made of record therein and appear among the "References Cited" issue therefrom.		
□ 1.	OR be	This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.		
<u> </u>	date A	This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.		
	☐ a.	I hereby certify that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. 37 C.F.R. §1.97(e)(1).		
	□ b.	I hereby certify that no item of information in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign		

			making reasonable inquiry, was known to any (c) more than three months prior to the filing of 37 C.F.R. §1.97(e)(2).	
	_ c.	§1.17(p). Please credit or debit Der	S180.00 in payment of the fee under 37 C.F.R. ossit Account No as needed to ensure ation. Two duplicate copies of this paper are	
3.	This Information Disclosure Statement is being filed more than three months after the U.S. filing date and after the mailing date of a Final Rejection or Notice of Allowance, but before payment of the Issue Fee. Applicant(s) hereby petition(s) that the Information Disclosure Statement be considered. Attached is our check no in the amount of \$180.00 in payment of the petition fee under 37 C.F.R. §1.17(p). Please credit or debit Deposit Account No as needed to ensure consideration of the disclosed information. Two duplicate copies of this paper are attached.			
	☐ a.	Statement was cited in a communicati	rmation contained in this Information Disclosure on from a foreign patent office in a counterpart the months prior to the filing of this Information e)(1).	
	□ b.	I hereby certify that no item of information in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to my knowledge after making reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this Information Disclosure Statement. 37 C.F.R. §1.97(e)(2).		
			Respectfully submitted,	
Date:	Sept	. II , 2008	Tristan A. Fuierer Reg. No. 52,926 Attorney for Applicant Moore & Van Allen, PLLC Telephone: (919) 286-8089	
			Facsimile: (919) 286-8199	